



PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Nathan R. Brown

Serial No.: 09/912,982

Filed: July 25, 2001

For: DIFFERENTIAL PRESSURE  
APPLICATION APPARATUS FOR USE IN  
POLISHING LAYERS OF  
SEMICONDUCTOR DEVICE  
STRUCTURES AND METHODS

Confirmation No.: 6766

Examiner: S. Macarthur

Group Art Unit: 1763

Attorney Docket No.: 2269-4375US  
(99-1029.00/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

July 2, 2004  
Date

*Rachael Harris*  
Signature

Rachael Harris  
Name (Type/Print)

AMENDMENT

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This Amendment is being filed in response to the Office Action mailed on April 2, 2004, the three-month shortened statutory period for response to which expires on July 2, 2004.

**Amendments to the claims** are set forth in the listing of the claims, which begins on page 2 of this paper; and

**Remarks** start at page 7 of this paper.